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#### Sommario/riassunto

Elliptical Mirrors: Applications in microscopy discusses the importance of the elliptical mirror; the third solution after parabolic reflectors and lenses for which apodization factors were established in 1921 and 1959 respectively. This detailed and highly insightful book will be an important reference in a growing subject area that will benefit PhD students, optical physicists, metrologists and researchers.

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